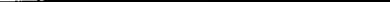


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OTHER ART - NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No.*	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
		J. THAYSEN et al., "Atomic Force Microscopy Probe . . . Wheatstone Bridge Arrangement", SENSORS AND ACTUATORS 83(2000) (pp. 47-53)	
		MASAMI KAGESHIMA et al., "Noncontat Atomic Force Microscopy . . . And Carbon Nanotube Probe", Applied Surface Science 188 (2002) (pp. 440-444)	
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		SUNG-Q LEE, et al., "Track/Focus Control . . . and Fast Data Transfer Rate Data Storage Device", ASPE 2002 Annual Meeting, Vol. 27, pp. 176-181.	
	1	SUNG-Q LEE, et a., "Non-contact Type AFM Using Frequency Separation Scheme", ABSTRACT, pp375-378	

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